

Robotics and Artificial Intelligence

Rodney Brooks

Director, MIT Computer Science and
Artificial Intelligence Laboratory

CTO, iRobot Corp



CSAIL



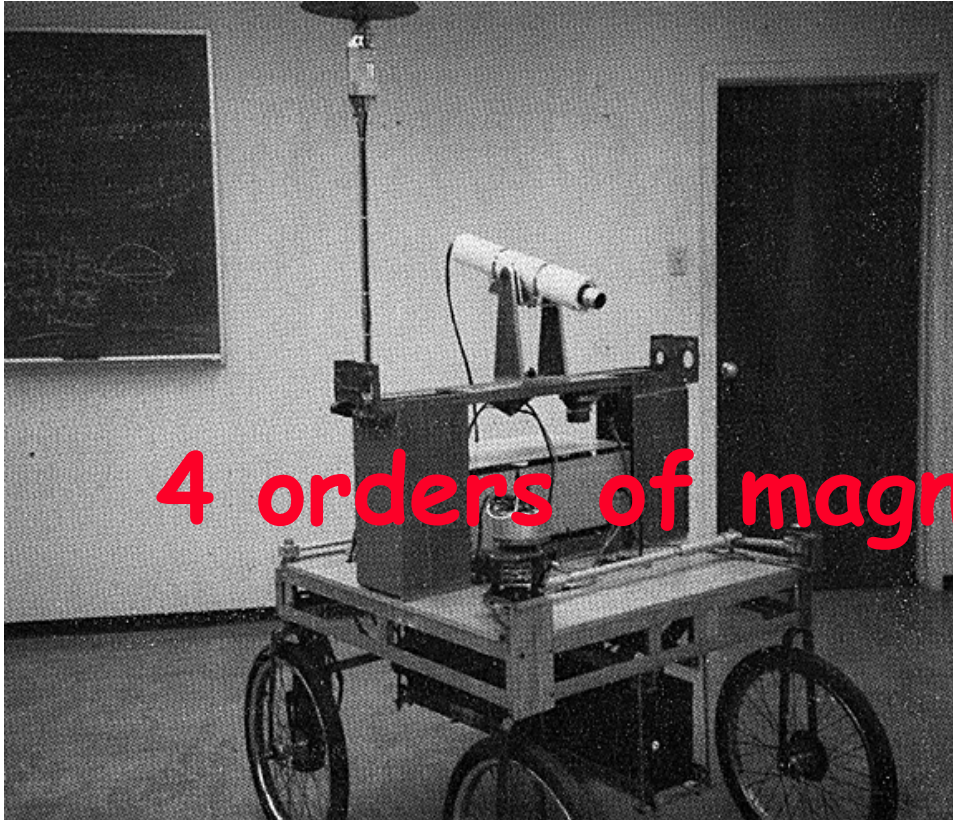
iRobot®

Report Documentation Page				Form Approved OMB No. 0704-0188	
Public reporting burden for the collection of information is estimated to average 1 hour per response, including the time for reviewing instructions, searching existing data sources, gathering and maintaining the data needed, and completing and reviewing the collection of information. Send comments regarding this burden estimate or any other aspect of this collection of information, including suggestions for reducing this burden, to Washington Headquarters Services, Directorate for Information Operations and Reports, 1215 Jefferson Davis Highway, Suite 1204, Arlington VA 22202-4302. Respondents should be aware that notwithstanding any other provision of law, no person shall be subject to a penalty for failing to comply with a collection of information if it does not display a currently valid OMB control number.					
1. REPORT DATE 06 MAR 2007		2. REPORT TYPE N/A		3. DATES COVERED -	
4. TITLE AND SUBTITLE Robotics and Artificial Intelligence				5a. CONTRACT NUMBER	
				5b. GRANT NUMBER	
				5c. PROGRAM ELEMENT NUMBER	
6. AUTHOR(S)				5d. PROJECT NUMBER	
				5e. TASK NUMBER	
				5f. WORK UNIT NUMBER	
7. PERFORMING ORGANIZATION NAME(S) AND ADDRESS(ES) MIT Computer Science and Artificial Intelligence Laboratory				8. PERFORMING ORGANIZATION REPORT NUMBER	
9. SPONSORING/MONITORING AGENCY NAME(S) AND ADDRESS(ES)				10. SPONSOR/MONITOR'S ACRONYM(S)	
				11. SPONSOR/MONITOR'S REPORT NUMBER(S)	
12. DISTRIBUTION/AVAILABILITY STATEMENT Approved for public release, distribution unlimited					
13. SUPPLEMENTARY NOTES DARPA Microsystems Technology Symposium held in San Jose, California on March 5-7, 2007. Presentations, The original document contains color images.					
14. ABSTRACT					
15. SUBJECT TERMS					
16. SECURITY CLASSIFICATION OF:			17. LIMITATION OF ABSTRACT UU	18. NUMBER OF PAGES 22	19a. NAME OF RESPONSIBLE PERSON
a. REPORT unclassified	b. ABSTRACT unclassified	c. THIS PAGE unclassified			

Stanford AI Lab



1979: 20 meters/6 hours

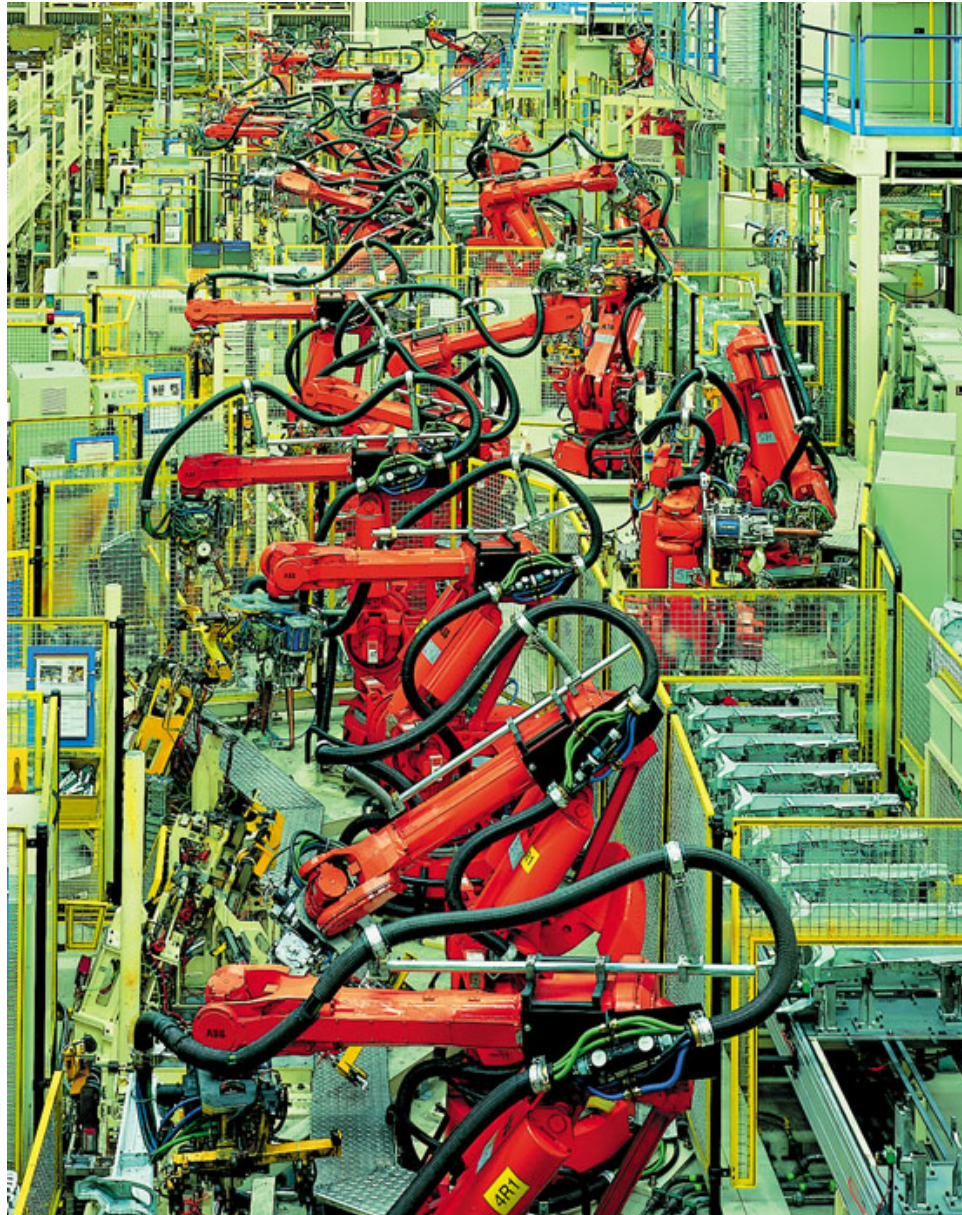


4 orders of magnitude in 26 years

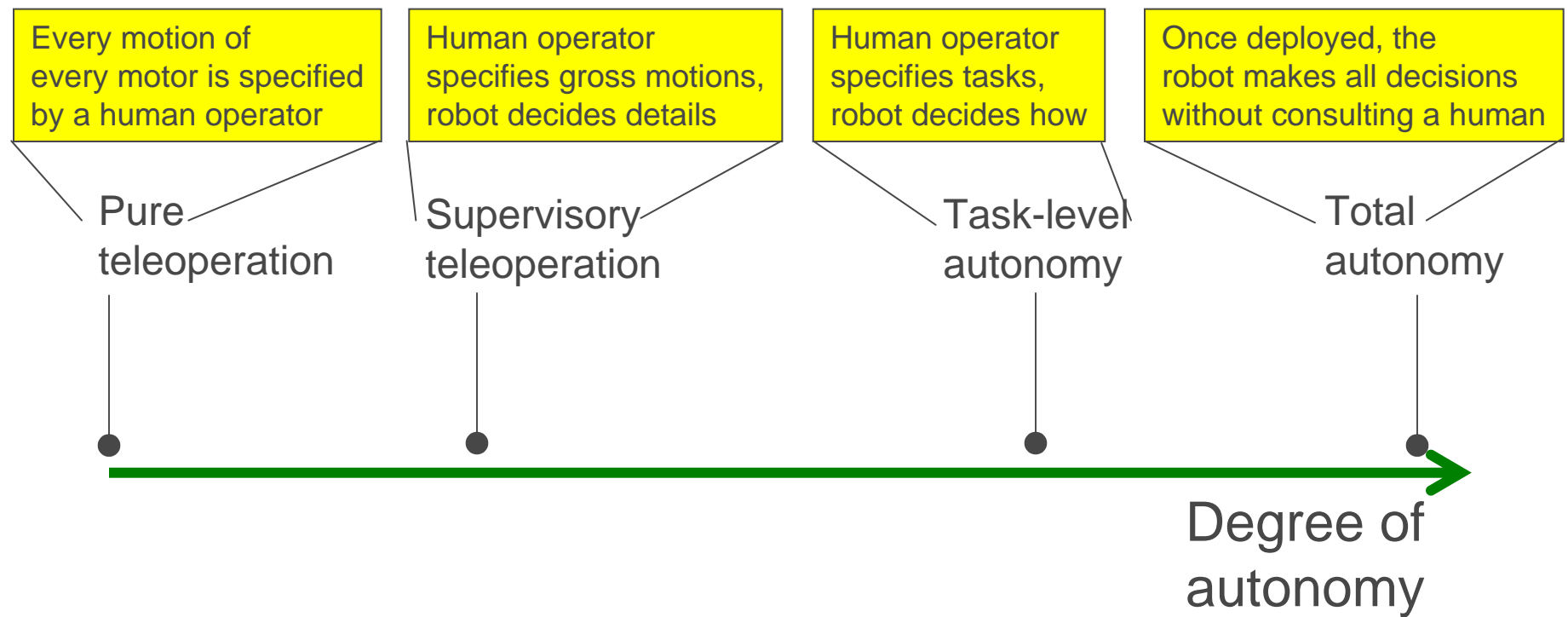
2005: 200 kilometers/6 hours



Our Recent View of Robots



Autonomy For Robots



Autonomy Levels



Pure
teleoperation



Supervisory
teleoperation



Task-level
autonomy

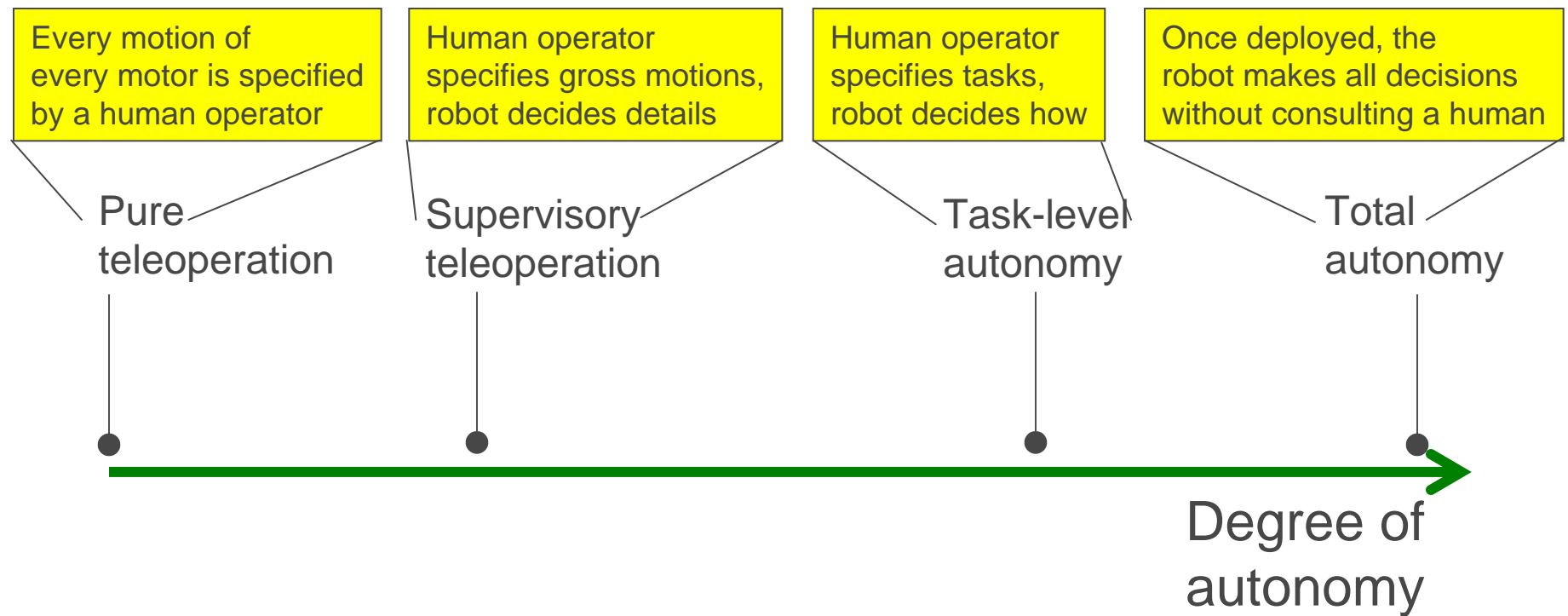


Total
autonomy



Degree of
autonomy

Autonomy For Robots



iRobot Autonomy Levels



Pure
teleoperation



Supervisory
teleoperation



Task-level
autonomy



Total
autonomy



Degree of
autonomy

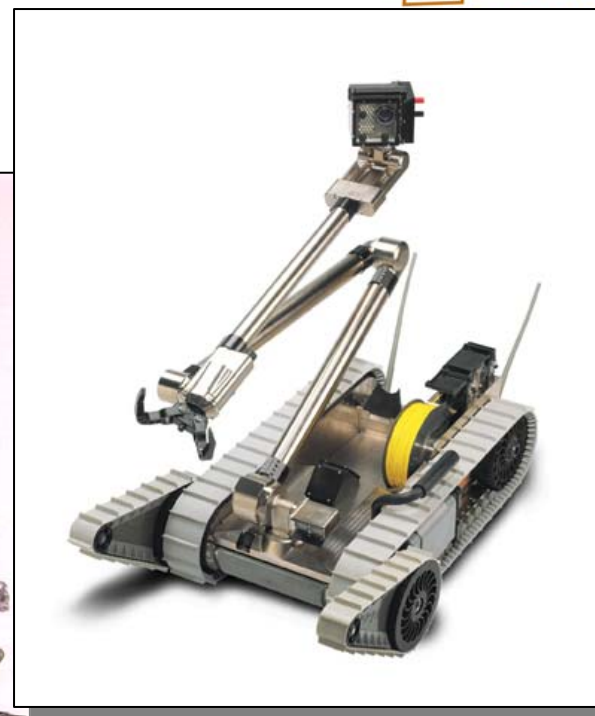


PackBot EOD





L



PackBot #129

Killed In Action
April 8, 2004
Iraq



iRobot®





iRobot®

Why Manipulation for Robots?



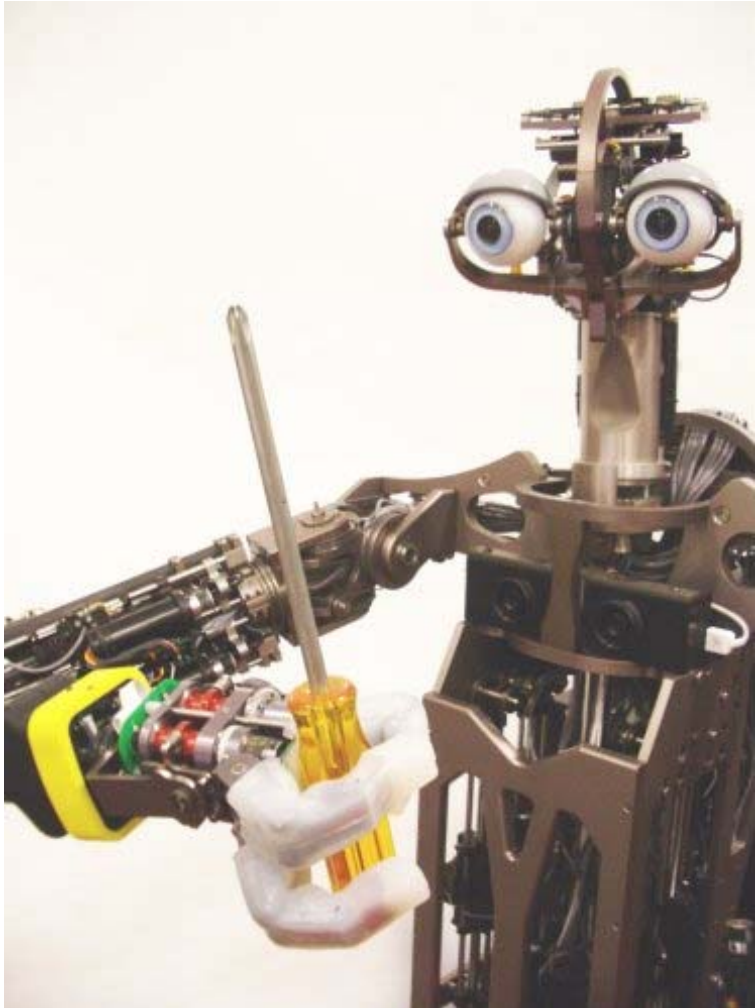
- Teleoperation of manipulation is slow and difficult
 - for EOD missions this is currently acceptable but not optimal
 - for tactical situations it is not acceptable
- Tasks for manipulation in tactical situations
 - opening doors
 - rapidly placing charges
 - poking and lifting
- Tasks for manipulation elsewhere
 - logistics and supply
 - casualty removal

State of Art in Robot Manipulation



- Deployed
 - pre-engineered in carefully controlled environments
 - pure (or marginally supervisory) teleoperation
 - » perhaps after a task-level or fully autonomous traverse
- Touch Sensors
 - mostly rigid
 - mostly require too much pressure
 - mostly measure only normal force

Lab Robots For Grasping



Force only



Force and touch

Pure Force Control

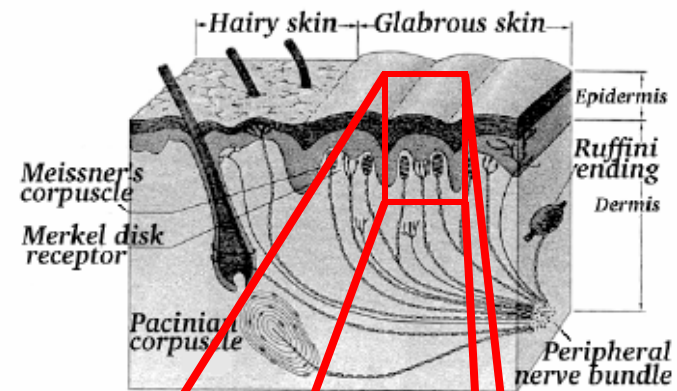


[Movie File](#)

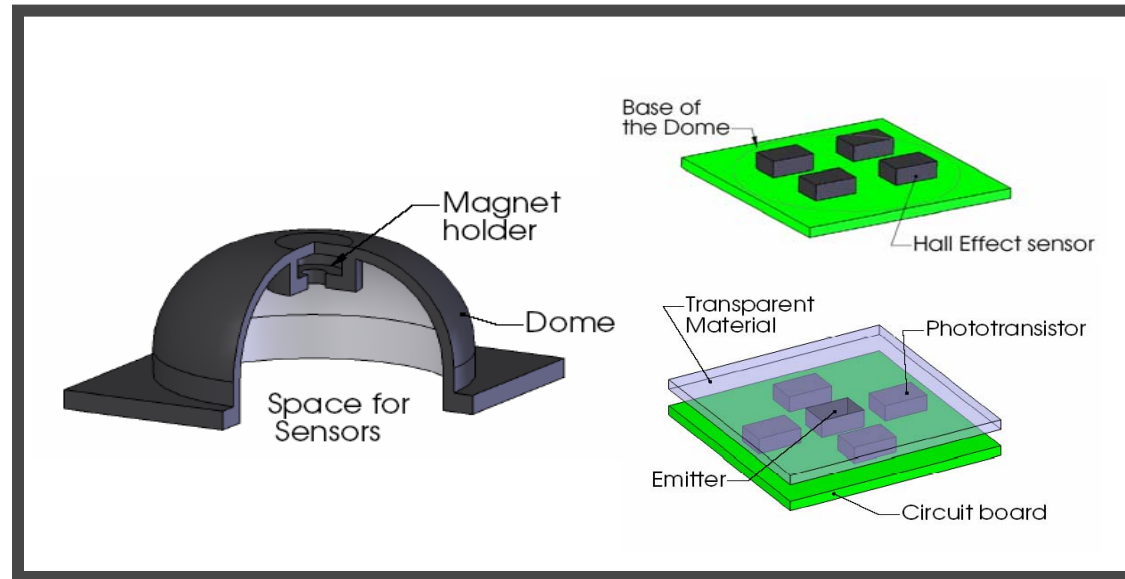
Our Approach to Touch



- Biological inspired sensors.
 - Dome shaped
 - Deformable
- Sensors favor compliance over spatial resolution.
- RIDGES



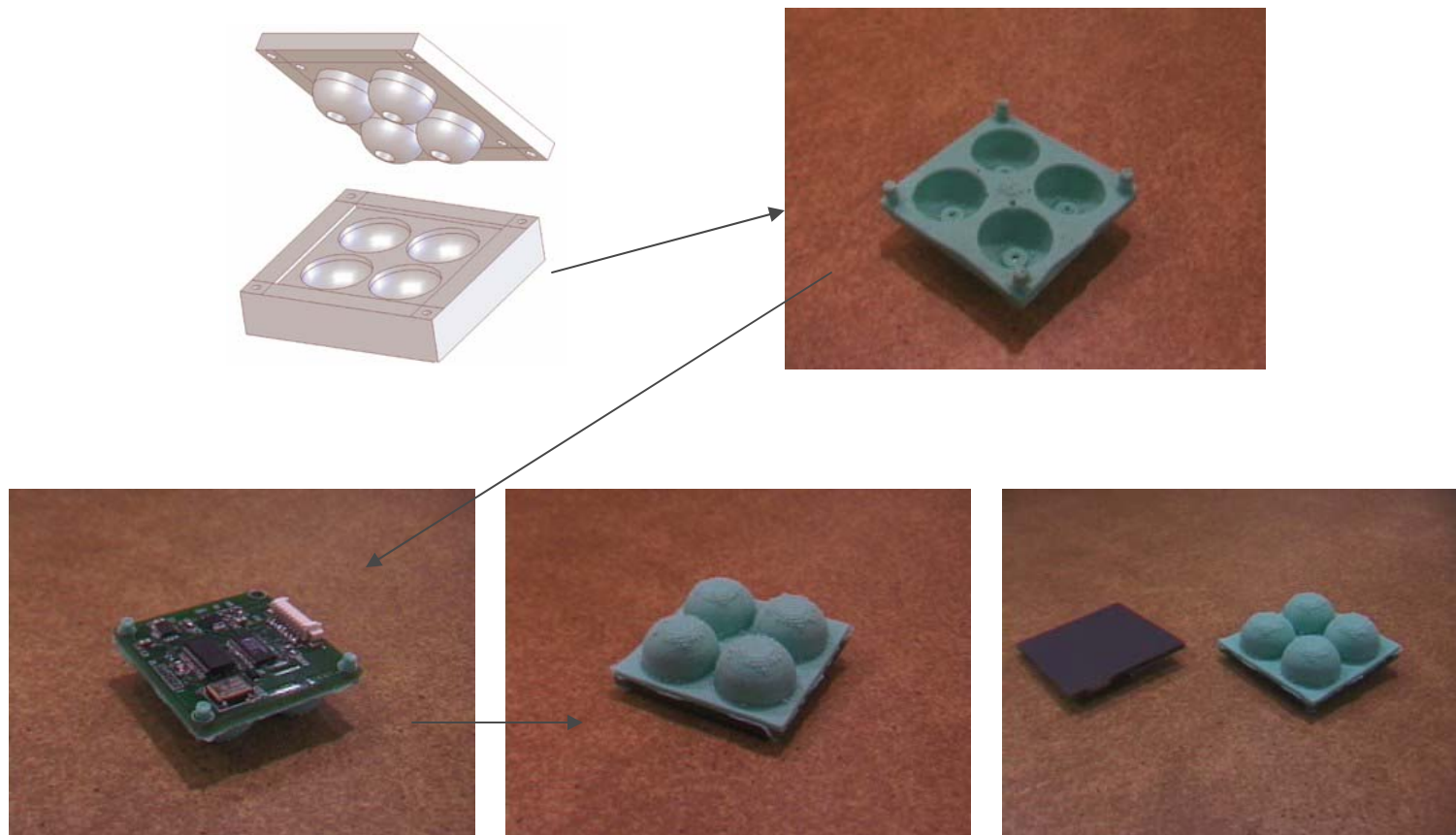
Approach to Tactile Sensing



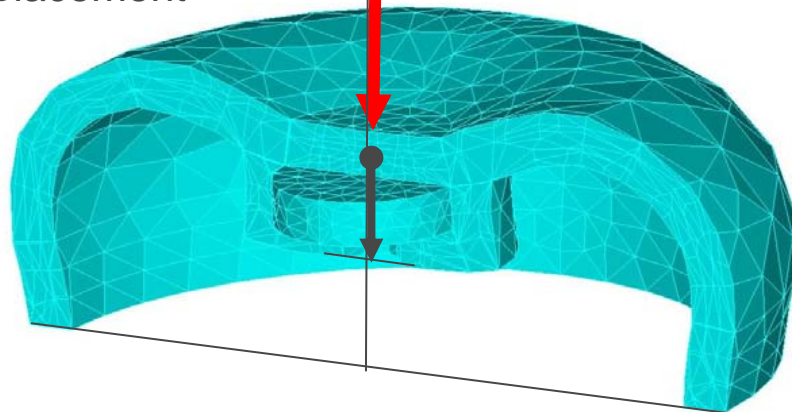
- Position of the top of the sensor gives an estimation of the force applied
- Magnetic:
 - A magnet on the dome, 4 hall effect sensors on the base
- Optical version
 - A LED and 4 photo receptors on the base

Sensor Prototyping

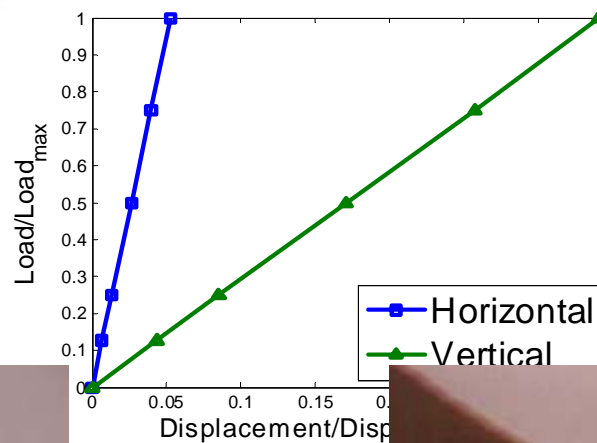
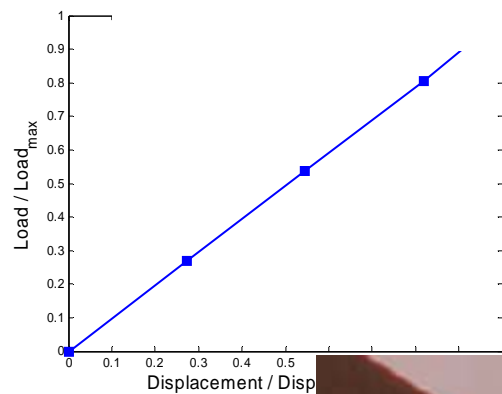
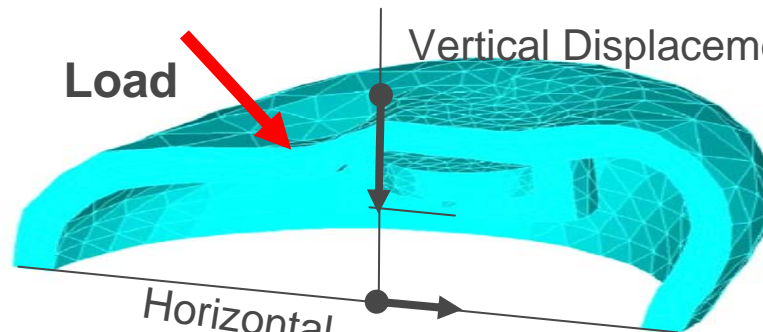
- Molding silicon rubber



Displacement Load



Load Vertical Displacement Horizontal Displacement





Movie File

Slip Detection + Correction



Micro Technology & Manipulation



- Embedded processing
 - for images, planning, control
- Tactile sensors
 - transistors in compliant materials
 - large arrays
 - sheets that can be cut and shaped
- Other tactile modalities
 - intertwined with temperature sensors
 - intertwined with sniffers
- More generally
 - not just faster, and lower power
 - embedded computation and sensing in materials